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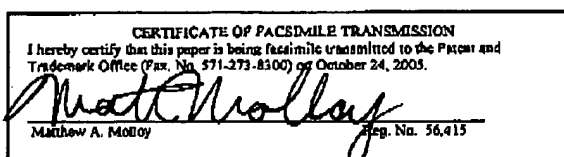
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OCT 24 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of
Applicants : Zheng et al.
Serial No. : 10/790,492
Filed : March 1, 2004
Title: : Atomic Layer Deposition of Capacitor Dielectric
Docket No. : MIO 0082 N2/40509.292
Examiner : Thomas, Toniae M
Art Unit : 2822
Conf. No. : 9512

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Sir or Madam:

AMENDMENT

This paper is being filed in response to the Office Action mailed July 22, 2005.
Reconsideration of the present application is respectfully requested in light of the amendments and remarks below, which include, in order of appearance, beginning on separate sheets:

- Amendments to the Claims; and
- Remarks.